

Docket No.: 2336-253

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of :  
Inventor(s): Jeong Goo YOON *et al.* :  
U.S. Patent Application No.: *Not yet assigned* : Group Art Unit: *Not yet assigned*  
Filed: *Herewith* :

For: METHOD FOR SEPARATING SAPPHIRE WAFER INTO CHIPS

**INFORMATION DISCLOSURE STATEMENT**

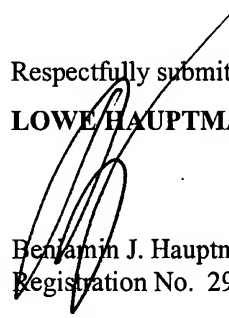
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,  
**LOWE HAUPTMAN GILMAN & BERNER, LLP**

  
Benjamin J. Hauptman  
Registration No. 29,310

1700 Diagonal Road, Suite 300  
Alexandria, Virginia 22314  
(703) 684-1111  
Facsimile: (703) 518-5499  
Date: March 23, 2004  
BJH/ayh

INFORMATION DISCLOSURE CITATION IN AN APPLICATION  (PTO-1449)							ATTY. DOCKET NO. 2336-253		U.S. APPLICATION NO. Not yet assigned		
							APPLICANT Jeong Goo YOON et al.				
							FILING DATE herewith		GROUP Not yet assigned		
U.S. PATENT DOCUMENTS											
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE					
	6,593,170	07/2003	Tateiwa et al.								
	6,465,158	10/2002	Sekiya								
FOREIGN PATENT DOCUMENTS											
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation Yes No					
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)											
EXAMINER					DATE CONSIDERED						

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.